

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	34	(cvd or vapor near2 deposit\$6) near10 (sic or silicon near2 carbide) near10 side near5 substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/05 12:25
L2	42	(cvd or vapor near2 deposit\$6) near10 (sic or silicon near2 carbide) near10 side near5 (substrate or wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/05 12:26
L3	95	(shigehiro near2 nishino or kazutoshi near2 murata).in.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/05 12:27
L4	36	(shigehiro near2 nishino or kazutoshi near2 murata).in. and (sic or silicon near2 carbide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/05 12:27
S1	143	("alpha." or ".beta." or alpha or beta) near10 cvd near10 sic	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/24 15:23
S2	2	"6053973".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/24 14:57
S3	4	"10055975"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/24 14:57
S4	1	"0916750"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/24 14:57
S5	11	"916750"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/24 14:57

EAST Search History

S6	26	(ring or annular\$6) near10 cvd near10 sic	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/24 15:29
S7	34	(cvd or vapor near2 deposit\$6) near10 (sic or silicon near2 carbide) near10 side near5 substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/06/05 12:25